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NO. 5562 P. 3

OFFICIAL

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel Stearns et al

Attorney Docket: CIL-10843

Serial No. : 09/896,722

Art Unit: 1765

Filed : June 29, 2001

Examiner: C. Brown

For : A Method To Repair Localized Amplitude
Defects In A EUV Lithography Mask Blank

AMENDMENT

Commissioner of Patents and Trademarks
Washington, D.C. 20231

Dear Sir:

In response to the Office Action mailed December 18, 2002, please amend the
above-referenced application as follows:

FAX RECEIVED
APR 21 2003
GROUP 1700